



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

Ammar Derraa

**Serial No.:** 10/654,226

**Filed:** September 2, 2003

**For:** METHOD OF FABRICATING FIELD EMISSION ARRAYS EMPLOYING A HARD MASK TO DEFINE COLUMN LINES AND ANOTHER MASK TO DEFINE Emitter TIPS AND RESISTORS

**Confirmation No.:** 4741

**Examiner:** M. Santiago

**Group Art Unit:** 2879

**Attorney Docket No.:** 2269-3882.8US  
(99-0017.08/US)

**Notice of Allowance Mailed:**

May 4, 2005

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Express Mail Mailing Label Number: EL994848217US

Date of Deposit with USPS: August 3, 2005

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Examiner:

Please amend the above-referenced application as follows:

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

**Amendments to the Specification** begin on page 3 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 5 of this paper.

**Remarks** begin on page 9 of this paper.